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S. I	Substitute for form 1449A/B/PTO			Complete if Known		
300	sume for form 144370 an			Application Number	10/646,673-Conf. #1020	
IN	FORMATIO	N DI	SCLOSURE	Filing Date	August 21, 2003	
•••	TATEMENT			First Named Inventor	Kevin L. Beaman	
				Art Unit	1762	
	(Use as many s	sheets as	necessary)	Examiner Name	David Turocy	
heet	1	of	2	Attorney Docket Number	108298715US	

	U.S. PATENT DOCUMENTS					
Examiner		-:-	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant
Initial		Cite No.1	Number-Kind Code <sup>2</sup> ( if known)	MM-DD-YYYY	Applicant of Cited Document	Figures Appear
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Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages	
Initials*	No.	Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>3</sup> (if known)		Applicant of Cited Pocument	or Relevant Figures Appear	Ľ
DPT		JP-63-111177-A	05-16-1988	Hitachi Ltd.		$oxed{\bot}$
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant. \* CITE NO.: Those application(s) which are marked with an single asterisk (\*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. Applicants unique citation designation number (optional). \* See Kinds Codes of USPTO Patent Documents at <a href="www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. \* Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). \* For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. \* Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. \* Applicant is to place a check mark here if English language Translation is attached.

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²			
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Examiner /David Turocy/	Date Considered	09/05/2006

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00000.000	10. 10			Application Number	10/646,673-Conf. #1020	
INFO	RMATI	ON DI	SCLOSURE	Filing Date	August 21, 2003	
STA	STATEMENT BY APPLICANT			First Named Inventor	Kevin L. Beaman	
				Art Unit	1762	
	(Use as many sheets as necessary)			Examiner Name	David Turocy	
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DPT	EMCO Flow Systems, "Mach One Mass Flow Controller Product Brochure" 6 pages, retrieved from the Internet on November 7, 2003, <a href="http://www.emcoflow.com/literature/brochures_product_sheets/mach_one/mach_one_brochure_2_01.pdf">http://www.emcoflow.com/literature/brochures_product_sheets/mach_one/mach_one_brochure_2_01.pdf</a> .
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&#</sup>x27;Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.